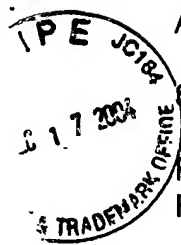


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TFW



Applicant(s): Karen Schlicht, et al.
Serial No.: 10/665,412
For: METHOD FOR THE REMOVAL OF AN IMAGING LAYER
FROM A SEMICONDUCTOR SUBSTRATE STACK

Filed: September 18, 2003

Examiner: Kripa Sagar

Art Unit: 1756

Confirmation No.: 4389

Customer No.: 27,623

Attorney Docket No.: 335.7697USU

REQUEST FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is a petition for extension of time for a total period of one (1) month. Based on the extension requested, the extended period for response will expire on December 13, 2004 (since December 11, 2004 falls on a Saturday).

A check in the amount of \$110.00 is enclosed with this Petition. The Commissioner is hereby authorized to charge any fees or credit any overpayment, to Deposit Account No. 01-0467. A duplicate copy of this Request is enclosed.

Respectfully submitted,

Paul D. Greeley, Esq.
Reg. No. 31,019
Attorney for Applicant(s)
Ohlandt, Greeley, Ruggiero & Perle, L.L.P.
One Landmark Square, 10th Floor
Stamford, CT 06901-2682
(203) 327-4500

Date: December 13, 2004

12/20/2004 RFEKADU1 00000006 10665412

01 FC:1251

120.00 03